

03560.002998.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YUKIKO IWASAKI ET AL.

Application No.: 10/083,585

Filed: February 27, 2002

For: METHOD FOR
MANUFACTURING A
SEMICONDUCTOR FILM

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:
) Examiner: Asok K. Sarkar

)
:
) Group Art Unit: 2829

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:
)
:
) August 26, 2003

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Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action dated May 27, 2003, please amend the
above-identified application as follows.

10/07/2003 AWISF1 00000010 061201 1004-0000
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